

Notice of References Cited

Application/Control No.

10/542,045

Applicant(s)/Patent Under
Reexamination
WERMTER ET AL.

Examiner

Katarzyna Wyrozewski

Art Unit

1796

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,084,197	08-2006	Chin et al.	524/99
*	B	US-7,371,793	05-2008	Gong et al.	524/445
	C	US-			
	D	US-			
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	F	US-			
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	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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